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CONFIRMATION NO. 6541

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/528,069	07/10/2006	438	2893	122733		
APPLICANTS Naoto Nakamura, Toyama, JAPAN; Iwao Nakamura, Toyama, JAPAN; Tomoharu Shimada, Nagasaki, JAPAN; Kenichi Ishiguro, Toyama, JAPAN; Sadao Nakashima, Toyama, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/12353 09/26/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-282231 09/27/2002 JAPAN 2003-051243 02/27/2003 JAPAN 2003-051244 02/27/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/17/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /HOA B TRINH/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 11	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 9
ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES						
TITLE Thermal Treatment Apparatus, Method For Manufacturing Semiconductor Device, And Method For Manufacturing Substrate						
FILING FEE RECEIVED 2230	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees			
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